## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of Confirmation No.: 5571

Masanobu SATO et al. Date: April 16, 2007

Serial No.: 10/767,756 Group Art Unit: 1746

Filed: January 28, 2004 Examiner: Mikhail Kornakov

For: SUBSTRATE TREATMENT METHOD AND SUBSTRATE TREATMENT

APPARATUS VIA EFS-WEB

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

## RESPONSE TO RESTRICTION REQUIREMENT AND AMENDMENT UNDER 37 C.F.R. §1.48(b)

Sir:

In response to the Office Action dated March 21, 2007, the applicants hereby elect the method invention, claims 1-4, without traverse.

In view of the cancellation of apparatus claims 5-13, please delete Shuichi YASUDA as an inventor whose invention is no longer being claimed in the present application. Credit card payment for the \$130.00 fee under 37 C.F.R. §1.17(i) is being submitted via EFS-WFB.

THIS CORRESPONDENCE IS BEING SUBMITTED ELECTRONICALLY THROUGH THE PATENT AND TRADEMARK OFFICE EFS FILING SYSTEM ON April 16, 2007.

Respectfully submitted,

Registration No.: 30,173

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